

Docket No. 209236US0

IN RE APPLICATION OF: Yoshihiro OGAWA, et al.

SERIAL NO: 09/867,541

FILED: May 31, 2001

FOR: COMPOSITION FOR POLISHING PAD AND POLISHING PAD USING THE SAME

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

Transmitted herewith is an amendment in the above-identified application.

- ☐ No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS	RATE	CALCULATIONS
TOTAL	22	MINUS	20	2	x \$18 =	\$36.00
INDEPENDENT	4	MINUS	4	0	x \$84 =	\$0.00
		<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS			+ \$280 =	\$0.00
		TOTAL OF ABOVE CALCULATIONS				\$36.00
		<input type="checkbox"/> Reduction by 50% for filing by Small Entity				\$0.00
		<input type="checkbox"/> Recordation of Assignment			+ \$40 =	\$0.00
		TOTAL				\$36.00

- ☒ A check in the amount of **\$36.00** is attached.
- ☒ Please charge any additional Fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.

Norman F. Oblon

Registration No. 24,618

Harris A. Pitlick

Registration No. 38,779



22850

Customer Number 22850
Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 10/01)



1711\$

RECEIVED
APR 14 2003
GROUP 1700

209236US-0



#10/C
4/16/03
A

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

:

TOSHIHIRO OGAWA ET AL

: GROUP ART UNIT: 1711

SERIAL NO.: 09/867,541

:

FILED: MAY 31, 2001

: EXAMINER: RAJGURU, U.

FOR: COMPOSITION FOR POLISHING PAD :
AND POLISHING PAD USING THE SAME

RECEIVED
APR 14 2003
GROUP 1700

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

#10

Responsive to the Office Action dated January 9, 2003, Applicants respectfully
request reconsideration of the above-identified application in view of the following
amendment and remarks.

#6